•		and the second second
•	Application No.	Applicant(s)
Notice of Allowability	09/827,248	HEMBREE, DAVID R.
	Examin r	Art Unit
	VINH P NGUYEN	2829
Th MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
 This communication is responsive to the ;amendment filed The allowed claim(s) is/are 68. The drawings filed on 04 April 2001 are accepted by the E Acknowledgment is made of a claim for foreign priority und All b) Some* c) None of the: Certified copies of the priority documents have Copies of the certified copies of the priority documents have 	xaminer. der 35 U.S.C. § 119(a)-(d) or (e been received. e been received in Application	No
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received: 5.		
9. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
Attachm nt(s)		
 1 □ Notice of References Cited (PTO-892) 3 □ Notice of Draftperson's Patent Drawing Review (PTO-948) 5 ☑ Information Disclosure Statements (PTO-1449), Paper No. 9 7 □ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	4∏ Interview . 6∏ Examiner'	Informal Patent Application (PTO-152) Summary (PTO-413), Paper No s Amendment/Comment s Statement of Reasons for Allowance

Application/Control Number: 09/827,248

Art Unit: 2829

1. The following is an examiner's statement of reasons for allowance: the prior art does not disclose a method of communicating signals with respect to a wafer having a combination of method steps of providing a workpiece holder, supporting a wafer using the holder, coupling circuitry of wafer with circuitry of the workpiece holder and communicating signals intermediate the circuitry of the wafer and the circuitry of the workpiece holder wherein the communicating comprises communicating using an intermediate member.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

VINH P. NGUÝEN PRIMARY EXAMINER

ART UNIT 2829

03/10/03